

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: De Simone *et al.* Confirmation No.: 8879
Appl No.: 10/583,570 Group Art Unit: 1615
Filed: 3/5/07 Examiner: H. Sheikh
For: METHODS FOR FABRICATING ISOLATED MICRO- AND NANO-
STRUCTURES USING SOFT OR IMPRINT LITHOGRAPHY

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT AND
PRELIMINARY AMENDMENT UNDER 37 CFR § 1.115**

In response to the Restriction dated October 4, 2010, please enter the following amendments in the above-identified application:

Amendments to the claims beginning on page 2 of this paper; and

Remarks beginning at page 21.